

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	Docket Number (Optional) <b>35706.5405</b>	Application Number <b>10/055,679</b>
	Applicant(s) <b>Kannan Raj et al.</b>	
	Filing Date <b>January 22, 2002</b>	Group Art Unit <b>2812</b>

U.S. PATENT DOCUMENTS							
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
25		JP 62 132385	06/15/87	Japan			✓	
1		JP 57 195209	11/30/82	Japan			✓	
1		FR 2 569 015	02/14/86	France				✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Bestwick T, "A Silicon-Based Integrated Optical Manufacturing Technology," May 25, 1998, pgs. 566-571
	Tran D. et al. "Monolithic Integrated Optical Micro-Bench for High Density Photonics Packaging," May 25, 1998, pgs. 588-591

EXAMINER <i>Rougha Wittle</i>	DATE CONSIDERED <i>26 Nov 02</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.